

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yoshihiro ITO et al. Application No.: 10/518,945 Confirmation No.: 4943 Filing or 371(c) Date: March 16, 2006 Title: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE	Art Unit: 2893 Examiner: T. Nguyen
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AMENDMENT UNDER 37 C.F.R. § 1.312

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with 37 CFR § 1.312, please amend the above-captioned application as follows:

- ☒ **Amendments to the Specification** begin on page 2 of this paper.
- ☐ **Amendments to the Claims** are reflected in the listing of the claims which begins on page of this paper.
- ☐ **Amendments to the Drawings** begin on page of this paper and include an attached replacement sheet. An **Appendix** including the amended drawing figures is attached following page of this paper.
- ☒ **Remarks/Arguments** begin on page 3 of this paper.

Please note, if a box is not checked, then no corresponding amendment is being made.